

#9 BAF/1752

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

is the application of

Kenichiro SATO, et al.

Attorney Docket No.: Q58614

Appln. No. 09/541,597

Group Art Unit: 1752

Confirmation No.: Unknown

Examiner: R. ASHTON

Filed: April 3, 2000

For: POSITIVE PHOTORESIST COMPOSITION FOR FAR ULTRAVIOLET
EXPOSURE

RECEIVED
NOV 26 2001
TC 1700

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

ATTN: BOX AF
Commissioner for Patents
Washington, D.C. 20231

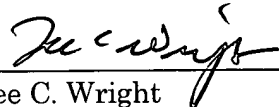
Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of July 23, 2001 to November 23, 2001.

Please charge the statutory fee of \$110.00 to Deposit Account No. 19-4880.

Please charge any additional fees under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

Respectfully submitted,


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